



PATENT

RCE 11w

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Kiermasz et al.

Application No: 10/607,613

Filed: June 27, 2003

For: PLATEN WITH DIAPHRAGM AND METHOD  
FOR OPTIMIZING WAFER POLISHING) Docket No: LAM2P421  
)  
) Examiner: Rachuba, M. T.  
)  
) Group Art Unit: 3723  
)  
) Date: August 29, 2005  
)  
)  
)

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being  
deposited with the United States Postal Service as First  
Class Mail to: Commissioner for Patents, Alexandria, VA  
22313-1450, on August 29, 2005.

Signed:

Kay Harlow

09/01/2005 SHASSEN1 00000048 10607613

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790.00 DP

## REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Mail Stop: RCE, Commissioner for Patents,  
Alexandria, VA 22313-1450

Sir:

This is a Request for Continued Examination (RCE) under 37 CFR 1.114 of the above-  
identified application.

## 1. Submission required under 37 C.F.R. § 1.114

- a. ☐ Previously submitted
- i. ☐ Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously  
filed on \_\_\_\_\_.
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously  
filed on \_\_\_\_\_.
- iii. ☐ Other \_\_\_\_\_.
- b. ☒ Enclosed
- i. ☒ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (IDS)
- iv. ☐ Other \_\_\_\_\_

## 2. Miscellaneous

- a. ☐ Suspension of action on the above-identified application is requested under 37  
C.F.R. § 1.103(c) for a period of \_\_\_\_\_ months.
- b. ☐ Other \_\_\_\_\_

## 3. Fees

- a. ☒ Check in the amount of \$790.00 is enclosed for:
- i. ☒ RCE fee required under 37 C.F.R. § 1.17(e);
- ii. ☐ Extension of time fee (37 C.F.R. §§ 1.136 and 1.17); and
- iii. ☐ Other \_\_\_\_\_.
- b. ☒ The Director is hereby authorized to charge any fees, or credit any  
overpayments, to Deposit Account No. 50-0805 (Order No. LAM2P421).

Date: August 29, 2005

  
Chester E. Martine, Jr.  
Registration No. 19,711  
Customer No. 25920